

# THz-Time Domain Spectroscopy and IR on MoS<sub>2</sub>

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In the increasing research field of 2D materials such as graphene, molybdenum disulfide MoS<sub>2</sub> attracted a great interest due to the existence of a direct bandgap in monolayer MoS<sub>2</sub>, which gives the possibility of performing MoS<sub>2</sub> field-effect transistors or optoelectronic devices. We analyzed by THz-Time Domain Spectroscopy (THz-TDS) up to 2 THz and infrared (IR) spectroscopy, CVD obtained MoS<sub>2</sub> using either S or H<sub>2</sub>S gas as a sulfur precursor, grown on a sapphire substrate. From THz-TDS

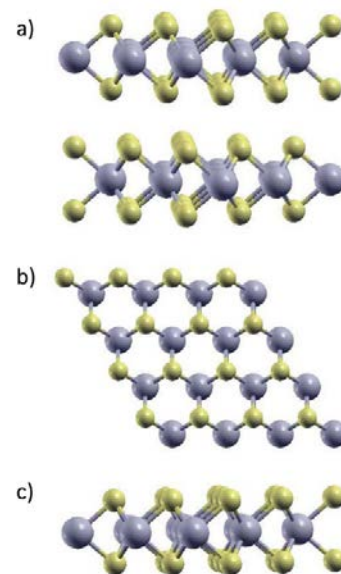
we obtained the transmittance, conductivity and attenuation. From IR spectroscopy on the same samples we deduced the transmittance at IR frequency range. We observed the coherence of both spectroscopic methods. The advantage of THz-TDS method is that we can get significant parameters related to the sample quality without the need of depositing any electrical contact or sample preparation. Our results show that at high frequencies MoS<sub>2</sub> is even better than graphene as a material for optoelectronic devices.

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**1 Introduction** Recent advances in fabrication of ultrathin layered materials down to atomic thickness have contributed towards the exploration of new low-dimensional physics.

Transition metal dichalcogenides have attracted considerable attention due to their potential applications as new materials in the fields of catalysis, nanotribology, microelectronics, lithium batteries, medical and optoelectronics [1, 2] with applications as thin film transistors, light-emitting diodes [3] or photodetectors [4]. In particular, molybdenum disulfide (MoS<sub>2</sub>) is a two-dimensional material that recently has attracted increasing attention. In the bulk MoS<sub>2</sub> crystal, S-Mo-S layers are Van der Waals bonded [5], each of these layers (MoS<sub>2</sub> monolayer) can be considered as two hexagonal planes of S atoms and an intermediate hexagonal plane of Mo atoms bonded by covalent interactions with the S atoms in a trigonal prismatic structure (Fig. 1).

It is well known that bulk MoS<sub>2</sub> has an indirect band gap of 1,29 eV, whereas the monolayer MoS<sub>2</sub> shows a direct band gap of 1,80 eV.



**Figure 1** a) Side view of bulk MoS<sub>2</sub>. b) Top view of bulk and monolayer MoS<sub>2</sub>, Mo atoms are presented by spheres bigger than S. So for bulk MoS<sub>2</sub>, the Mo atoms of 2<sup>nd</sup> layer must be seen. c) - Side view of monolayer MoS<sub>2</sub>. The Mo-atoms are depicted by gray and S-atoms by yellow [6].

Terahertz (THz) spectroscopy and imaging provides a powerful tool for the characterization of different kind of materials, including semiconductors. In the last few years

there has been an increasing interest in terahertz imaging and spectroscopy for optoelectronic applications, and more and more terahertz characterization are being reported [7, 8].

The infrared spectroscopy (IR) analysis is important for its role in optoelectronic implementations. Both graphene and MoS<sub>2</sub> characterization on the THz and IR bands are a key requirement for its applications and development on optoelectronic devices.

**2 Sample preparation and characterization** We analyzed an overall of 4 samples of pristine graphene transferred on a polyethylene terephthalate (PET) substrate and 4 samples of MoS<sub>2</sub> grown on sapphire substrates.

**Table 1** Summary of samples S<sub>i</sub>, graphene or MoS<sub>2</sub> and their substrate, analyzed in the current study. Sample identification are used for later reference.

Substrate	Material	Sample	Growth	Number of samples
PET	Graphene	S <sub>1</sub>	CVD	4
Sapphire	MoS <sub>2</sub>	S <sub>2</sub>	CVD-S	2
Sapphire	MoS <sub>2</sub>	S <sub>3</sub>	CVD-H <sub>2</sub> S	2

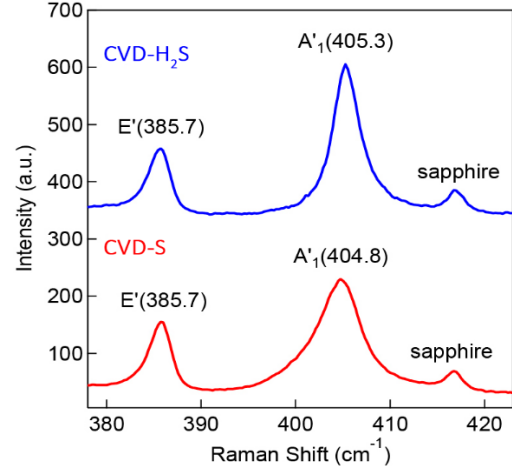
Graphene are obtained by chemical vapor deposition (CVD) transferred on a PET substrate and MoS<sub>2</sub> are obtained by CVD-S and CVD-H<sub>2</sub>S, table 1, described briefly in the next section. Samples S<sub>1</sub> are obtained at Sejong University as described in [9], and S<sub>2</sub> and S<sub>3</sub> are from the École Polytechnique Fédérale de Lausanne (EPFL) as described in [10].

Structural quality, homogeneity and domain size are described in ref [10] for MoS<sub>2</sub>, and in ref [11] for graphene. Domain size is from 5 to 10 μm for MoS<sub>2</sub>, and from 1 to 5 μm for graphene. Structural quality is tested by Raman, that shows good quality with low amount of defects.

**2.1 CVD-S MoS<sub>2</sub> and CVD-H<sub>2</sub>S MoS<sub>2</sub>** Chemical vapor deposition (CVD) is the most promising method to synthesize monolayer materials. In particular, MoS<sub>2</sub> can be obtained from triangular islands up to a large-scale film, depending on the growing conditions.

For sample CVD-S we used the commonly CVD method, which involves a solid sulfur source plus an inert gas (Ar) as a carrier gas flow. For CVD-H<sub>2</sub>S we used a gas-phase precursor, a mixture H<sub>2</sub>S:H<sub>2</sub> at different conditions of temperature and mixture ratio. Selecting both conditions allow us to regulate the growth direction: when the injected gas temperature is 600°C or lower and the ratio H<sub>2</sub>S:H<sub>2</sub> = 3:1, the growing is horizontal and a centimeter-scale MoS<sub>2</sub> monolayer is obtained, showing a morphology based on triangular shape domains that merge in a continuous film [10].

**2.2 Raman characterization** Raman spectroscopy is performed with an excitation laser of 532 nm, with a pin hole size of 150 μm, 100x objective, and a power of 0.5 mW that ensures the non-degradation of the sample. A quick and accurate sample identification (Fig. 2) are given by the Raman spectra.



**Figure 2** (Color online) From top to bottom, Raman spectra of CVD-H<sub>2</sub>S MoS<sub>2</sub>, S<sub>3</sub>, and CVD-S MoS<sub>2</sub>, S<sub>2</sub>, on sapphire substrate.

Like graphene, single-layer and few-layer MoS<sub>2</sub> has distinctive signatures in its Raman spectrum. The Raman spectrum of bulk MoS<sub>2</sub> has two prominent peaks: an in-plane mode (E<sub>2g</sub><sup>1</sup> or E' on Fig. 2) located around 383 cm<sup>-1</sup> and an out-of-plane mode (A<sub>1g</sub> or A' on Fig. 2) which is located at 408 cm<sup>-1</sup>. The E<sub>2g</sub><sup>1</sup> line corresponds to the sulfur atoms vibrating in one direction and the molybdenum atom in the other, while the A<sub>1g</sub> line corresponds to just the sulfur atoms vibrating out-of-plane. As MoS<sub>2</sub> becomes single-layer, the in-plane and out-of-plane modes, E<sub>2g</sub><sup>1</sup> and A<sub>1g</sub>, evolve with thickness. The in-plane mode upshifts to 385 cm<sup>-1</sup> and the out-of-plane downshifts to 403 cm<sup>-1</sup> [12].

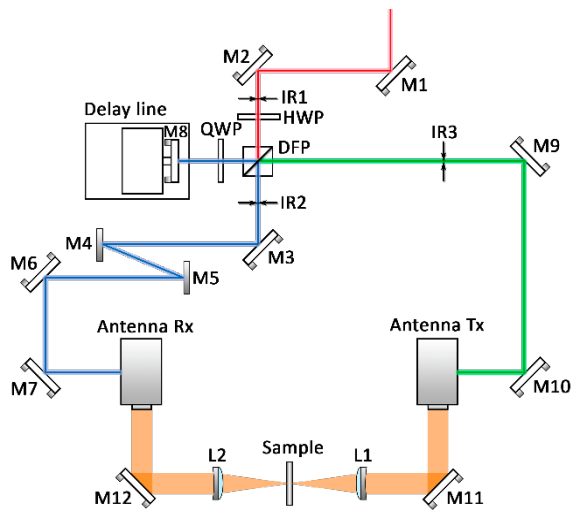
Both CVD-S and CVD-H<sub>2</sub>S MoS<sub>2</sub> present similar Raman spectra but with some important differences. Both materials present an E<sub>2g</sub><sup>1</sup> line located at 385.7 cm<sup>-1</sup>, while the out-of-plane vibration, A<sub>1g</sub>, are located at different frequencies, at 404.8 cm<sup>-1</sup> (for sample CVD-S) and 405.3 cm<sup>-1</sup> (for CVD-H<sub>2</sub>S). The difference between A<sub>1g</sub> and E<sub>2g</sub><sup>1</sup> modes for both samples are ~20 cm<sup>-1</sup>, therefore, we can assume that both MoS<sub>2</sub> are monolayers [12]. The softening and broadening of the out-of-plane A<sub>1g</sub> mode could be explained by different doping levels of MoS<sub>2</sub>, increasing the doping level causes broadening on the A<sub>1g</sub> mode and decreases the intensity ratio between A<sub>1g</sub> and E<sub>2g</sub><sup>1</sup> modes, indicating in our case a greater doping level for sample CVD-S [13].

The different A<sub>1g</sub> mode position in Raman spectra between presented CVD-S and previous results corresponds to slightly different grown conditions of MoS<sub>2</sub> [14].

Raman spectra were taken using different sample zones, from 5 to 10 different points. In most of them the spectra are similar.

### 3 Experimental

**3.1 THz-Time Domain Spectroscopy** Terahertz time-domain spectroscopy (THz-TDS) is a contactless, non-destructive spectroscopic technique based on a coherent detection scheme. Material complex properties can be measured at THz frequencies, up to 2 THz, by using a phase-sensitive technique. The THz measurements are collected using a THz-TDS spectrometer in transmission setup, based on the commercial TERA K8, from Menlo Systems (Fig. 3).



**Figure 3** THz-TDS transmission setup configuration.

Broadband THz radiation is generated by using a 780 nm wavelength fs laser and is later detected with a photoconductive antenna. The output of the laser is split into a pump (generating) and a probe (detecting) beams using a polarizing beam splitter, where each of these beams travel through two different optical paths to the emitter and the detector antenna, respectively.

The probe (detecting) path implements a variable length using a delay line, to control the pulses delay arriving to the receiver antenna.

The pump (generating) beam is collimated to the emitter antenna with the purpose to produce a THz electric field that is transmitted through the sample and is modified by its frequency response. The beam spot size at the sample surface is about 550  $\mu\text{m}$ , after the Menlo Systems specifications, but it could be slightly larger, close to 1 mm, when working. The modified electric field is focused on a THz detector photoconductive antenna, which is gated by the probe (detection) laser beam. As a result, a time-domain electric field pulse is obtained. The recorded time-domain trace is transformed into the frequency domain by using the Fourier transform (FFT) for spectroscopic analy-

sis. From the frequency spectra, the refractive index, the conductance and attenuation of the sample can be deduced.

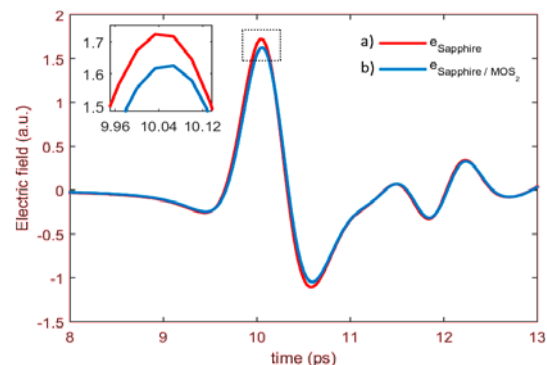
### 3.2 THz-TDS experimental results

We analyze, using the THz time-domain spectroscopy, the conductivity of different  $\text{MoS}_2$  samples grown on sapphire and, just for comparison, CVD obtained graphene [11] transferred on a PET substrate at high frequencies, from 100 GHz to 2 THz.

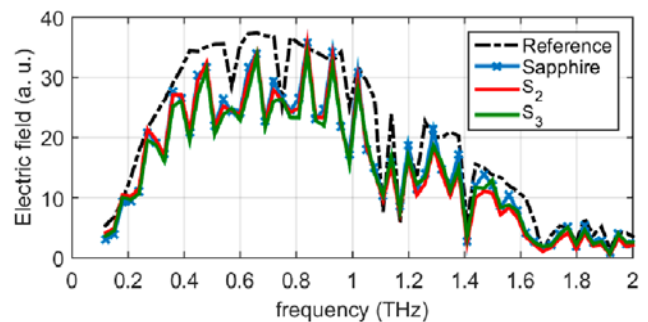
From the time-domain electric field, see Fig. 4, provided by the THz-TDS spectroscopic method, we obtain its THz spectrum, see Fig. 5, by applying the FFT on the time signal. Hence, we obtain information of both the amplitude and the phase of the THz waves in frequency domain.

By analyzing the time domain electric field (Fig. 4), we observe that a monolayer  $\text{MoS}_2$  on sapphire substrate causes a 5.68% decrement at the maximum value of the temporal pulse, as we see in the inset.

Since water has a strong absorption in many of the frequency bands in the THz range, high relative humidity of the environment would therefore greatly affect the frequency spectra at certain frequencies. The water absorption of the THz wave causes an absorption peak in the frequency spectra of the measured temporal electric field (Fig. 5).

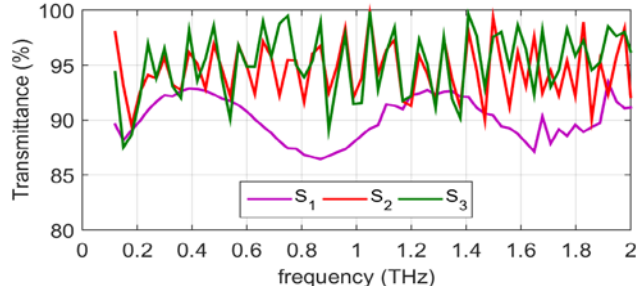


**Figure 4** (Color online) Time-domain electric field pulse of the transmitted THz wave through a) the bare sapphire substrate and b) the  $\text{MoS}_2$  grown on a sapphire surface, corresponding to sample  $S_2$ .



**Figure 5** (Color online) Frequency spectrum of the measured temporal electric field pulse of the transmitted THz wave through

the reference (air), the bare substrate (sapphire) and the MoS<sub>2</sub> grown on a sapphire surface, corresponding to samples S<sub>2</sub> and S<sub>3</sub>.



**Figure 6** (Color online) MoS<sub>2</sub> and graphene transmittance. On the left, from top to bottom: (S<sub>2</sub>) CVD-S MoS<sub>2</sub> on sapphire, (S<sub>3</sub>) CVD-H<sub>2</sub>S MoS<sub>2</sub> on sapphire and (S<sub>1</sub>) CVD graphene on PET.

Transmittance represents the intensity portion of the THz wave transmitted through a material and air is used as the transmission reference. Hence, transmittance is defined as the ratio between the frequency domain wave transmitted through the sample and the reference wave, as follows:

$$T(\omega) = \frac{FFT[e(t)]}{FFT[e(t)_{reference}]} \quad (1)$$

MoS<sub>2</sub> and graphene transmittance (Fig. 6) are retrieved by using the ratio of the sample (material and substrate) and the bare substrate transmittance:

$$T(\omega)_{material} = \frac{T(\omega)_{material+substrate}}{T(\omega)_{substrate}} \quad (2)$$

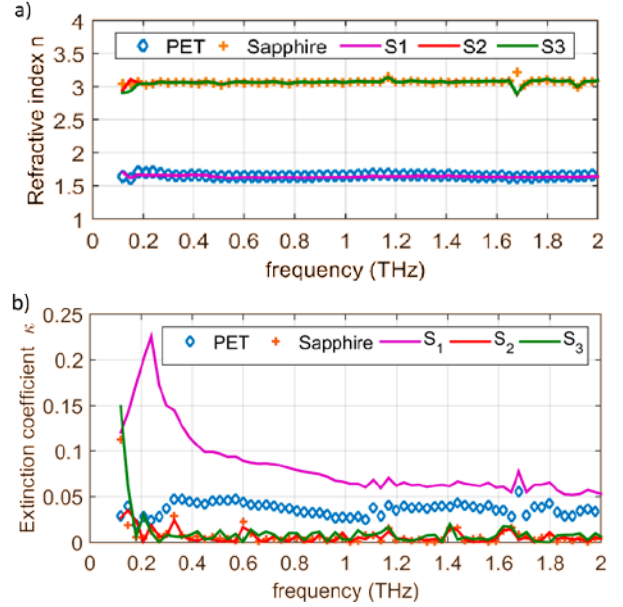
The internal Fabry-Pérot reflections, related to the substrate thickness, cause a set of the oscillations seen on Fig. 6.

Graphene (S<sub>1</sub>) transmittance in the THz ranges from 87% to 93% approximately, whereas CVD-S and CVD-H<sub>2</sub>S MoS<sub>2</sub> (S<sub>2</sub> and S<sub>3</sub> respectively) show a transmittance close to 95%.

Using the transmittance of the sample and the bare substrate, we are able to determine a large set of optoelectronic properties, such as the complex refractive index (Fig. 7), the sheet conductivity of graphene and MoS<sub>2</sub> (Fig. 8), and their attenuation (Fig. 9), among others [11, 15].

First, we characterize the complex refractive indices, see Fig. 7, of the PET and sapphire substrates, by comparing the substrate signal spectrum with the reference (air) spectrum, whereas we minimize the internal Fabry-Pérot reflection effects produced in thin films [15]. With the complex refractive index, we are able to characterize the substrate and then, we can evaluate the sheet conductivity of MoS<sub>2</sub> and graphene [15].

We found that by growing MoS<sub>2</sub> or transferring graphene on to the bare substrate surface, see Fig. 7a, has no bearing on the values of the sample refractive index.



**Figure 7** (Color online) a) Real part of the refractive indices and b) Imaginary part of the refractive indices of substrates, and the samples composed of the material grown on to the substrate surface. On the left, from top to bottom, Sapphire, (S<sub>2</sub>) CVD-S MoS<sub>2</sub> on sapphire, (S<sub>3</sub>) CVD-H<sub>2</sub>S MoS<sub>2</sub> on sapphire, graphene on PET (S<sub>1</sub>) and PET.

We deduced the sheet conductivity of MoS<sub>2</sub> and graphene deposited on their respective substrates. To obtain the MoS<sub>2</sub> and graphene conductivity, we have treated them as boundary condition with finite sheet conductivity [15]:

$$T(\omega) = \frac{4\chi \cdot n_{sub}}{n_{sub} + 1} \exp(-j(n_{sub} - 1)k_0 d_{sub}) \cdot \sum_{FP=0}^N \left( \exp(-2jn_{sub}k_0 d_{sub}) \frac{n_{sub} - 1}{n_{sub} + 1} (2n_{sub} \chi - 1) \right)^{FP} \quad (3)$$

Where  $\chi^{-1} = 1 + n_{sub} + \sigma_s Z_0$ ;  $n_{sub}$  and  $d_{sub}$  are the substrate complex refractive index and thickness, respectively;  $k_0$  is the free-space wave number,  $Z_0$  is the free-space impedance,  $\sigma_s$  is the surface conductivity of the thin film, and  $FP$  corresponds to the internal Fabry-Pérot reflections. As the sample thickness is about a hundred  $\mu\text{m}$ , we can consider that infinite internal reflections occur in a thin layer, and (Eq. (3)) can be simplified:

$$T(\omega) = \frac{4\chi \cdot n_{sub}}{n_{sub} + 1} \exp(-j(n_{sub} - 1)k_0 d_{sub}) \cdot \frac{1}{1 - \exp(-2jn_{sub}k_0 d_{sub}) \frac{n_{sub} - 1}{n_{sub} + 1} (2n_{sub} \chi - 1)} \quad (4)$$

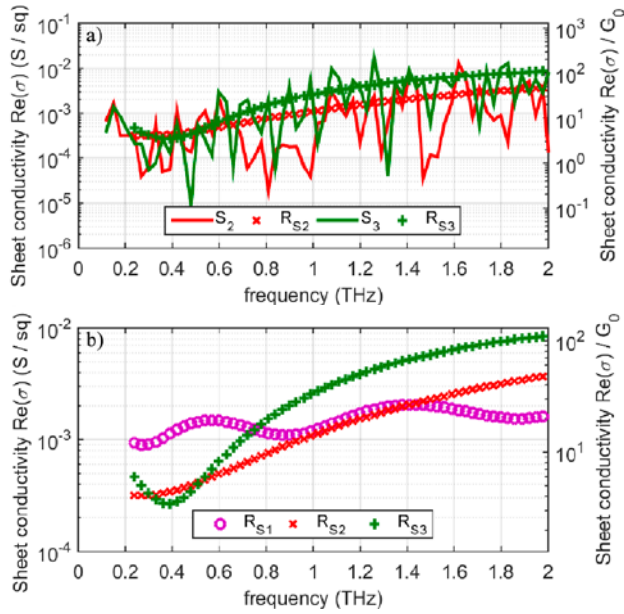


**Table 2** Real part of refractive indices of the substrates, sheet conductivity's smooth values and normalized sheet conductivity of the material  $\sigma_s$  (in mS) and normalized sheet conductivity's smooth values  $\sigma_n$  of the material at 1 THz, 1.5 THz and 2 THz, normalized to the conductance quantum,  $G_0$ .

Substrate	Sample	Growth	Material	n	$\sigma_n$ (1 THz)	$\sigma_s$ (1 THz)	$\sigma_n$ (1.5 THz)	$\sigma_s$ (1.5 THz)	$\sigma_n$ (2 THz)	$\sigma_s$ (2 THz)
PET	S <sub>1</sub>	CVD	Graphene	1.65	15.28	1.18	25.98	2.01	20.89	1.62
Sapphire	S <sub>2</sub>	CVD-S	MoS <sub>2</sub>	3.07	13.93	1.08	29.59	2.29	47.95	3.72
Sapphire	S <sub>3</sub>	CVD-H <sub>2</sub> S	MoS <sub>2</sub>	3.07	32.89	2.55	75.14	5.82	109.39	8.48

Finally, with all the parameters known, we can extract the MoS<sub>2</sub> and graphene conductivity, see Fig. 8, reported on the right by its normalized conductance quantum units, denoted by the symbol  $G_0$ , defined as the quantum unit of electrical conductance:

$$G_0 = \frac{2e^2}{h} \approx 77.48 \mu S \quad (5)$$



**Figure 8** (Color online) Real part of sheet conductivity of MoS<sub>2</sub> and graphene. a) Sheet conductivity of: CVD-S MoS<sub>2</sub>, S<sub>2</sub>, and CVD-H<sub>2</sub>S MoS<sub>2</sub>, S<sub>3</sub>. RS<sub>2</sub> and RS<sub>3</sub> are a graphical representation of the smooth curve that shows the tendency of the sheet conductivity of CVD-S and CVD-H<sub>2</sub>S MoS<sub>2</sub>, respectively. b) On the left, from top to bottom: smooth curve of real part of sheet conductivity of (S<sub>1</sub>) CVD graphene on PET, (S<sub>3</sub>) CVD-H<sub>2</sub>S MoS<sub>2</sub> on sapphire and (S<sub>2</sub>) CVD-S MoS<sub>2</sub> on sapphire.

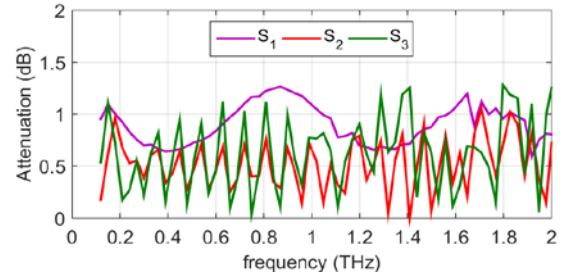
As seen in Fig. 8, CVD pristine graphene presents a sheet conductivity around 12-25× the value of quantum conductance,  $G_0$ , at frequencies of THz, as expected from previous studies [16, 17]. MoS<sub>2</sub>, on the other hand, has a slight difference in values depending on the growth conditions. CVD-S MoS<sub>2</sub>, S<sub>2</sub>, shows a sheet conductivity around 4.5-42× the value of  $G_0$  whereas CVD-H<sub>2</sub>S MoS<sub>2</sub>, S<sub>3</sub>, presents values 1.3-3 times greater than CVD-S, in the range from 3.4-130× the value of  $G_0$ .

By comparing graphene and MoS<sub>2</sub>, we observed some different results depending on the frequency range. Specifically, at frequencies below to 750 GHz, graphene sheet conductivity is feebly higher than both CVD-S and CVD-H<sub>2</sub>S MoS<sub>2</sub>. From 1 to 1.5 THz, CVD-S MoS<sub>2</sub> sheet conductivity is similar to graphene. Finally, at frequencies greater than 1.5 THz, both CVD-S and CVD-H<sub>2</sub>S MoS<sub>2</sub> sheet conductivities are slightly higher, up to 3 times, than graphene.

We obtained the attenuation of both MoS<sub>2</sub> and graphene. Attenuation is defined as the intensity loss wave propagation, as follows:

$$A(\omega) = 20 \log_{10} (|T(\omega)|) \quad (6)$$

Attenuation of graphene and MoS<sub>2</sub> are illustrated on Fig. 9. We found that CVD pristine graphene, S<sub>1</sub>, presents an attenuation from 0.6 to 1.2 dB, whereas MoS<sub>2</sub>, shows an attenuation below than 1.8 dB, in detail, CVD-S MoS<sub>2</sub> attenuation, S<sub>2</sub>, takes values from 0.1 to 1.7 dB and CVD-H<sub>2</sub>S MoS<sub>2</sub>, S<sub>3</sub>, from 0.1 to 1.8 dB.

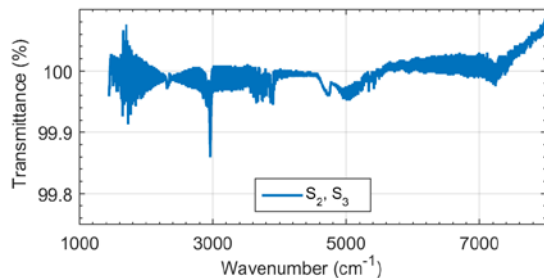


**Figure 9** (Color online) Attenuation of MoS<sub>2</sub> and graphene. On the left, from top to bottom: (S<sub>1</sub>) CVD graphene on PET, (S<sub>3</sub>) CVD-H<sub>2</sub>S MoS<sub>2</sub> on sapphire and (S<sub>2</sub>) CVD-S MoS<sub>2</sub> on sapphire.

**3.3 Infrared spectroscopy** We studied MoS<sub>2</sub> transmittance in the infrared band, see Fig. 10, in the range from 400 cm<sup>-1</sup> to 8000 cm<sup>-1</sup>. Graphene IR spectroscopy is reported on reference [11]. Measures have been collected with the Frontier FT-IR/FIR Spectrometer from Perkin Elmer at CCiTUB.

It is important to emphasize that, as the MoS<sub>2</sub> transmittance is extracted by comparison (Eq. (2)) using substrate transmittance, we can only determine the material transmittance as long as the transmittance of both the sample and the bare substrate are not null. Therefore, because the sapphire transmittance is null at wavenumber below to

1700  $\text{cm}^{-1}$ , we can only study the transmittance of  $\text{MoS}_2$  in the range from 1700  $\text{cm}^{-1}$  to 8000  $\text{cm}^{-1}$ , where  $\text{MoS}_2$  present values of transmittance close to 99.8%, see Fig. 10.



**Figure 10** (Color online) IR transmittance of  $\text{MoS}_2$ .

**4 Discussion and conclusions** We have characterized electronic properties of CVD  $\text{MoS}_2$  and graphene over the THz and IR range.

We studied electronic properties of CVD monolayers of  $\text{MoS}_2$  depending on the growth conditions, by controlling the growth direction of  $\text{MoS}_2$  domains using  $\text{H}_2\text{S}$  as a gas-phase precursor (CVD- $\text{H}_2\text{S}$ ), in addition to conventional sulfur (CVD-S).

We found that CVD-S  $\text{MoS}_2$  presents a sheet conductivity of  $4.5\text{-}42\times$  the value of quantum conductance,  $G_0$ , whereas CVD- $\text{H}_2\text{S}$   $\text{MoS}_2$  presents values in the range from  $3.4\text{-}130\times$  the value of  $G_0$ , while graphene shows a sheet conductivity around  $12\text{-}25\times$  the value of  $G_0$ . Therefore, we found that CVD monolayer  $\text{MoS}_2$  sheet conductivity, at frequencies in the range 1 – 2 THz, is up to 3 times greater for  $\text{MoS}_2$  obtained using  $\text{H}_2\text{S}$  as a sulfur gas precursor than the usual CVD  $\text{MoS}_2$  obtained with sulfur. Probably, because the former is more ordered.

The attenuation on differently obtained  $\text{MoS}_2$  in the THz range are presented, and for comparison, also the graphene attenuation. We observed that monolayer  $\text{MoS}_2$  shows an attenuation below than 1.8 dB. In comparison, graphene presents an attenuation from 0.6 to 1.2 dB, similar to  $\text{MoS}_2$ .

The study of a material transmittance is a key factor to characterize a material over a wide frequency range. We found that at THz frequencies, from 100 GHz to 2 THz, CVD-S and CVD- $\text{H}_2\text{S}$   $\text{MoS}_2$  transmittance is close to 95%, similar to graphene. On the other hand, at IR wavenumbers, CVD-S and CVD- $\text{H}_2\text{S}$   $\text{MoS}_2$  transmittance is close to 99.8%. Therefore, the use of  $\text{MoS}_2$  is very promising in the development of optoelectronic devices, with similar properties than graphene. Moreover, the existing gap in  $\text{MoS}_2$  will provide the possibility to perform transistors for flexible or transparent electronics.

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